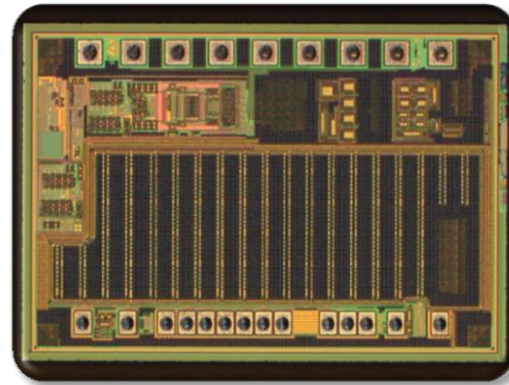


LIS3DH

3-Axis MEMS Accelerometer



Basic Product Analysis Report

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To Know

